



IPW

501.36127CC3

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: KOUBUCHI et al

Serial No.: 10/619,039

Filed: July 14, 2003

For: Semiconductor Integrated Circuit Device

Group: 2814

Examiner: L. Pham

**INFORMATION DISCLOSURE**  
**STATEMENT UNDER 37 CFR 1.97 & 1.98**

Mail Stop: DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 20, 2005

Sir:

In the matter of the above-identified application, applicants are submitting herewith a copy of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

The following statement specified in 37 CFR 1.97(e).

On information and belief, each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

To the extent the documents listed on the attached form equivalent to Form PTO-1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language version or translation of the foreign patent office report citing the documents.

It is respectfully requested that this information disclosure statement be

considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus Deposit Account No. 01-2135 (Case: 501.36127CC3), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

A handwritten signature in black ink, appearing to read 'Alan E. Schiavelli', is written over a horizontal line.

Alan E. Schiavelli  
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Attachments

Form PTO-1449 Equivalent	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DKT. NO. 501.36127CC3	SERIAL NO. 10/619,039
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use several sheets if necessary)		<b>APPLICANT</b> Koubuchi et al.	
		<b>FILING DATE</b> 7/14/03	<b>GROUP</b> 2814

**U.S. PATENT DOCUMENTS**

Ex. Initial	Doc. No.	Date	Name	Class	Subclass	Filing Date
AA						
AB						
AC						
AD						
AE						
AF						
AG						
AH						

**U.S. PATENT APPLICATIONS**

	Publication Number	Name	Publication Date
AI			
AJ			
AK			
AL			

**FOREIGN PATENT DOCUMENTS**

	Doc. No.	Date	Country	Class	Subclass	Translation/Abstract?	
						Yes	No
AM	08-288295	11/1/96	Japan			Abstract	
AN	09-181159	7/11/97	Japan			Abstract	
AO							
AP							
AQ							

**OTHER DOCUMENTS**

AR	Office Action of Korean Application No. 10-1998-0010428 dated January 31, 2005 with English language translation.				
AS					
AT					
<table border="1"> <tr> <td>Examiner</td> <td>Date Considered</td> </tr> <tr> <td></td> <td></td> </tr> </table>		Examiner	Date Considered		
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